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AMENDMENT TRANSMITTAL LETTER				Docket No. 8733.565.00-US	
Application No. 10/025,907 - Conf. #7489	Filing Date December 26, 2001	Examiner Marianne L. Padgett	Art Unit 1762		
Applicant(s): Yun-Ho JUNG					
Invention: APPARATUS AND METHOD OF CRYSTALLIZING AMORPHOUS SILICON					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	14	- 20 =	0	x	0.00
Independent Claims	3	- 3 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					0.00
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <span style="margin-left: 200px;"><input type="checkbox"/> Small Entity</span>					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0911</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<div style="display: flex; align-items: center; justify-content: center;"><div style="text-align: left; margin-right: 10px;">for <u>Valerie P. Hayes</u> Penny L. Caudle Attorney Reg. No.: 46,607</div><div style="text-align: right; margin-left: 10px;">Reg. No. <u>53,005</u></div></div>				Dated: <u>August 23, 2005</u>	
MCKENNA LONG & ALDRIDGE LLP 1900 K Street, N.W. Washington, DC 20006 (202) 496-7500					



Docket No.: 8733.565.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Yun-Ho JUNG

Customer No.: 30827

Application No.: 10/025,907

Confirmation No.: 7489

Filed: December 26, 2001

Art Unit: 1762

For: APPARATUS AND METHOD OF  
CRYSTALLIZING AMORPHOUS SILICON

Examiner: Marianne L. Padgett

**AMENDMENT AFTER FINAL REJECTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated May 23, 2005, Applicant proposes to amend the patent application identified above as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.